IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

Hiroshi Tayanal

TORNEY DOCKET NO. P97,0027

SERIAL NO.

08/818,239

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GROUP ART UNIT: 2813

FILING DATE:

March 14, 199

EXAMINER: K. Christiansen

INVENTION:

THIN FILM SEMICONDUCTOR, "METHOD FOR

SOLAR CELL, AND LIGHT EMITTING DIODE"

SUBMISSION OF SUPPLEMENTAL DECLARATION AND POWER OF ATTORNEY AND COPY OF ENGLISH TRANSLATION OF JAPANESE PRIORITY DOCUMENT RECEIVED

Asst. Commissioner of Patents Washington, D.C. 20231

FEB 15 2000

TECHNOLOGY CENTER 2800

SIR:

Applicant submits herewith a supplemental Declaration and Power of Attorney fully executed by the inventor of record in the above-identified patent application. The attached Declaration and Power of Attorney correctly claims priority to parent Japanese priority application No. P07-037655 as well as Japanese applications Nos. P08-061552 filed March 18, 1996 and P08-234480 filed September 4, 1996.

Also enclosed is an English translation of the Japanese priority document P07-037655.

A check in the amount of \$130.00 to cover the required fee for submitting the enclosed Declaration is enclosed. However, the Commissioner is hereby authorized to charge any additional fees which may be required, or to credit any overpayment to account No. 08-2290. A duplicate of this sheet is enclosed

Respectfully submitted,

OK to Enter

David R. Metzger

02/10/2000 ASAHLE 00000048 08181239

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130.00 OP

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Attorneys for Applicant

CERTIFICATE OF MAILING

| I hereby certify that this Submission is being deposited with the United States Po | stal |
|---|------|
| Service as First Class mail in an envelope addressed to: Hon. Commissioner of Patents | and |
| Trademarks, Washington, D.C. 20231 on February 4, 2000. | |

David R. Metzger

February 4, 2000